Notice of References Cited Application/Control No. 10/526,409 Examiner Nguyen T. Ha Applicant(s)/Patent Under Reexamination TAKAZAWA, TOMOO Art Unit Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-6,589,446	07-2003	Nakamura et al.	252/363.5
*	В	US-6,582,796	06-2003	Joulin et al.	428/116
*	С	US-6,252,481	06-2001	Iwao et al.	336/83
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.